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T. Steptu
5-27-03

PATENT
Atty. File No: 83975

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: Satoshi Kitagawa

Serial No.: 09/696,117

Filed: October 25, 2000

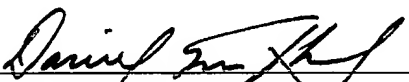
For: **MARKING METHOD FOR SEMICONDUCTOR
WAFER**

Examiner: Lisa M. Caputo

) Confirmation No. 4414

) Group Art Unit: 2876

) I hereby certify that this correspondence is
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REPLY AND AMENDMENT AFTER FINAL

Mail Stop BOX RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Dear Sir:

In response to the Office Action dated January 14, 2003, please amend the above-identified application as follows: